

In re: Sumakeris et al.  
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This listing of claims will replace all prior versions and listings of the claims in the application.

**In the Claims:**

1. (Currently amended) A housing assembly for an induction heating device, the housing assembly defining a processing chamber and comprising:
  - a) a susceptor surrounding at least a portion of the processing chamber;  
and
  - b) a thermally conductive liner interposed between the susceptor and the processing chamber, wherein the liner is separately formed ~~from~~ from the susceptor[.];
  - c) wherein the liner is removable from the susceptor without requiring disassembly of the susceptor.
2. (Original) The housing assembly of Claim 1 including:
  - a first susceptor portion and a second susceptor portion disposed on opposed sides of the processing chamber;
  - a first liner disposed between the first susceptor portion and the processing chamber; and
  - a second liner disposed between the second susceptor portion and the processing chamber.
3. (Previously presented) A housing assembly for an induction heating device, the housing assembly defining a processing chamber and comprising:
  - a) a susceptor surrounding at least a portion of the processing chamber;  
and
  - b) a thermally conductive liner interposed between the susceptor and the processing chamber, wherein the liner is separately formed from the susceptor;
  - c) wherein the susceptor includes a platter region, the housing assembly further including:

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a platter adapted to support the article disposed in the processing chamber and overlying the platter region; and  
an opening defined in the liner and overlying the platter region.

4. (Original) A housing assembly for an induction heating device, the housing assembly defining a processing chamber and comprising:
- a) a susceptor surrounding at least a portion of the processing chamber; and
  - b) a thermally conductive liner interposed between the susceptor and the processing chamber, wherein the liner is separately formed from the susceptor;
  - c) wherein the liner varies in thickness along at least a portion of its length.
5. (Previously presented) A housing assembly for an induction heating device, the housing assembly defining a processing chamber and comprising:
- a) a susceptor surrounding at least a portion of the processing chamber; and
  - b) a thermally conductive liner interposed between the susceptor and the processing chamber, wherein the liner is separately formed from the susceptor;
  - c) wherein the susceptor includes a susceptor core of a first material and a susceptor coating of a second material;
  - d) wherein the second material is selected from the group consisting of refractory metal carbides; and
  - e) wherein the liner is interposed between the susceptor coating and the processing chamber.
6. (Original) The housing assembly of Claim 5 wherein the second material is TaC.
7. (Original) The housing assembly of Claim 5 wherein the first material is

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graphite.

8. (Previously presented) The housing assembly of Claim 3 wherein the platter region is exposed through the opening in the liner.

9. (Previously presented) The housing assembly of Claim 3 wherein the platter is received in the opening in the liner.

10. (Previously presented) The housing assembly of Claim 3 wherein the platter is adapted to rotate relative to the susceptor.

11. (Previously presented) The housing assembly of Claim 4 wherein the liner contacts the susceptor.

12. (Previously presented) The housing assembly of Claim 5 wherein the liner includes a portion formed of SiC interfacing with the processing chamber.